

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No.09/847,165
 Confirmation No.5640
 Filing Date May 1, 2001
 Inventor.....David A. Atkinson, et al.
 Assignee.....BechtelBWXT Idaho, LLC
 Group Art Unit.....2881
 ExaminerGurzo, Paul M.
 Attorney's Docket No.LIT-PI-355
 Customer No.21567
 Title: Simultaneous Vaporization and Ionization Source for Particulate Matter Analysis by
 Ion Mobility Spectrometry and Atmospheric Pressure Ionization Mass Spectrometry

STATEMENT OF THE SUBSTANCE OF SEPTEMBER 17, 2003 INTERVIEW

On September 17, 2003, an interview was conducted by telephone concerning the above referenced application. Participants of the interview were Examiner Paul M. Gurzo and Robert C. Hyta. The interview did not include any exhibits or demonstrations. In response to the Office communication dated July 11, 2003, I, Robert C. Hyta, do hereby set forth the substance of such interview.

The interview was initiated by Robert C. Hyta. It was concluded that ion chamber 11 of the Lewis reference does not include a reference device and a conductive conduit.

Respectfully submitted,

Dated: 10/5/03

By: [Signature]

Robert C. Hyta
 Reg. No. 46,791

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